



EXPRESS MAIL NO. EV741784077US

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Osama Khouri et al.
Application No. : 10/756,195
Filed : January 13, 2004
For : SUBLITHOGRAPHIC CONTACT STRUCTURE, IN PARTICULAR FOR A PHASE CHANGE MEMORY CELL, AND FABRICATION PROCESS THEREOF
Examiner : Thanhha S. Pham
Art Unit : 2813
Docket No. : 854163.412
Date : March 2, 2006

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT TRANSMITTAL

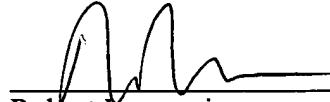
Commissioner for Patents:

In accordance with 37 CFR 1.56 and 1.97 through 1.98, applicants wish to make known to the U.S. Patent and Trademark Office the references set forth on the attached Information Disclosure Statement. Copies of cited U.S. patents and published patent applications are not required and accordingly have not been provided. Copies of any other cited references are enclosed. As to any reference cited, applicants do not admit that it is "prior art" under 35 U.S.C. §§ 102 or 103, and specifically reserve the right to traverse or antedate any such reference, as by a showing under 37 CFR 1.131 or other method. Although the aforesaid references are made known to the Patent and Trademark Office in compliance with applicants' duty to disclose all information they are aware of which is believed relevant to the examination of the above-identified application, applicants believe that their invention is patentable.

Please acknowledge receipt of this Information Disclosure Statement and kindly make the cited references of record in the above-identified application.

A fee of \$180 is submitted in accordance with 37 CFR 1.97(c). The Director is authorized to charge any other fees which may be required, or credit any overpayment to Deposit Account No. 19-1090.

Respectfully submitted,
Seed Intellectual Property Law Group PLLC



Robert Iannucci
Registration No. 33,514

RXI:lmt

Enclosures:

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Information Disclosure Statement
Cited References (2)

701 Fifth Avenue, Suite 6300
Seattle, Washington 98104-7092
Phone: (206) 622-4900
Fax: (206) 682-6031

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FORM PTO-1449 (RPT-10) <i>4589</i> <i>MAR 02 2006</i> <i>ATTEN & TRADEMARK OFFICE</i>		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. 854163.412	APPLICATION NO. 10/756,195
		INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)		APPLICANTS Osama Khouri et al.	
				FILING DATE January 13, 2004	GROUP ART UNIT 2813

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
AA	5,789,277	08/04/98	Zahorik et al.	438	95	
AB	5,814,527	09/29/98	Wolstenholme et al.	438	5	
AC	5,952,671	09/14/99	Reinberg et al.	257	3	
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AE	6,031,287	02/29/00	Harshfield	257	734	
AF	6,238,946	05/29/01	Ziegler	438	50	
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AN	2003/0219924	11/27/03	Bez et al.	438	102	
AO	2003/0231530	12/18/03	Bez et al.	365	200	
AP	2004/0012009	01/22/04	Casagrande et al.	257	4	
AQ	2004/0166604	08/26/04	Ha et al.	438	102	
AR	09/276,273		Klersy			03/25/99

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION	
				YES	NO
AS	WO 00/57498	09/28/00	WIPO		

EXAMINER _____ DATE CONSIDERED _____

* EXAMINER: Initial if reference considered, whether or not criteria is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant(s).

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	AG						
	AH						
	AI						
	AJ						

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					YES NO
	AK				
	AL				
	AM				
	AN				
	AO				

OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)

AP		Palun, L., et al., "Fabrication of Single Electron Devices by Hybrid (E-Beam/DUV) Lithography," <i>Microelectronic Engineering</i> 53:167-170, 2000.
AQ		
AR		

EXAMINER	DATE CONSIDERED
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